

Laser Processing Of Materials

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1;Preface;6 2;Contents;8 3;Contributors;14 4;Chapter 1: Introduction;16 4.1;References;18 5;Chapter 2: Basics of Lasers and Laser Optics;19 5.1;2.1 Introduction;19 5.2;2.2 Optical Processes;19 5.3;2.3 Time Dependence;22 5.3.1;2.3.1 Q-Switching;22 5.3.2;2.3.2 Mode-Locking;23 5.3.3;2.3.3 Ultrashort Pulse Generation;23 5.3.4;2.3.4 Harmonic Generation;23 5.4;2.4 Free-Electron Lasers;24 5.5;2.5 Laser Optics;26 5.5.1;2.5.1 Optical Propagation;27 5.5.2;2.5.2 Sizing Optical Elements and Other Tricks of the Trade;28 5.5.3;2.5.3 Fiber Optics;28 5.5.4;2.5.4 Managing Diffraction;29 5.5.5;2.5.5 The Aspheric Lens Beamshaper;29 5.5.6;2.5.6 Holographic Optical Elements;30 5.5.7;2.5.7 Laser Damage;31 5.5.8;2.5.8 Optical Modeling Software;33 5.6;2.6 Conclusions;33 5.7;References;33 6;Chapter 3: Fundamentals of Laser-Material Interactions;35 6.1;3.1 Basic Considerations;35 6.2;3.2 Laser;36 6.3;3.3 Heat in Solids: Electronic and Lattice Dynamics;37 6.4;3.4 Laser-Material Interactions;41 6.4.1;3.4.1 Single Photon and Multi-Photon Processes;41 6.4.2;3.4.2 Laser Reflection and Absorption;42 6.4.3;3.4.3 Temperature Profiles;45 6.5;3.5 Phenomena Occurring on the Target Surface;49 6.5.1;3.5.1 Vaporization;49 6.5.2;3.5.2 Recondensation;50 6.5.3;3.5.3 Plasma Formation;51 6.5.4;3.5.4 Laser Supported Absorption Waves;53 6.6;3.6 Material Transport Phenomena;56 6.7;3.7 Conclusions;58 6.8;References;58 7;Chapter 4: Laser Plasma Interactions;62 7.1;4.1 Introduction;62 7.2;4.2 Fundamentals of Laser Plasma Interaction;63 7.3;4.3 Processes in Nanosecond Laser Plasma Interactions;68 7.3.1;4.3.1 Laser-Induced Gas Breakdown;68 7.3.2;4.3.2 Plasma Shielding During Laser Material Processing;72 7.3.2.1;4.3.2.1 Target Vaporization;72 7.3.2.2;4.3.2.2 Plasma Ignition in the Vapor;73 7.3.2.3;4.3.2.3 Plasma Ignition in the Ambient Gas;74 7.3.2.4;4.3.2.4 The Role of Surface Defects;74 7.3.3;4.3.3 Laser-Supported Absorption Waves;76 7.3.3.1;4.3.3.1 Definition and Modeling;76 7.3.3.2;4.3.3.2 Propagation Modes;78 7.3.4;4.3.4 Plasma Shutter for Optical Limitation;79 7.3.4.1;4.3.4.1 Mechanisms and Characteristic Times;79 7.3.4.2;4.3.4.2 Plasma Shutter Applications;81 7.4;4.4 Plasma Interactions with Femtosecond Laser Pulses;82 7.4.1;4.4.1 Laser Beam Filamentation;82 7.4.1.1;4.4.1.1 Mechanisms and Processes;82 7.4.1.2;4.4.1.2 Applications of Laser Beam Filamentation;85 7.4.2;4.4.2 Generation of XUV Radiation by Laser Plasma;88 7.4.2.1;4.4.2.1 Pulsed XUV Radiation Sources: A Review;88 7.4.2.2;4.4.2.2 Laser

Plasma X-Ray Sources;90 7.4.2.3;4.4.2.3 High-Order Harmonic Generation;90 7.4.3;4.4.3 Plasma Mirror;93 7.4.3.1;4.4.3.1 Short Laser Pulse cleaning' by Plasma Mirrors;93 7.4.3.2;4.4.3.2 Harmonic Generation by Plasma Mirror;95 7.5;4.5 Conclusion;96 7.6;References;97 8;Chapter 5: Laser Ablation and Thin Film Deposition;102 8.1;5.1 Pulsed Laser Ablation;102 8.2;5.2 Lasers Used for Laser Ablation;104 8.3;5.3 Initial Ablation Processes and Plume Formation;105 8.3.1;5.3.1 Femtosecond Laser Irradiation;106 8.3.2;5.3.2 Nanosecond Laser Irradiation;106 8.4;5.4 Plume Expansion;107 8.4.1;5.4.1 Plume Expansion in Vacuum;107 8.4.2;5.4.2 Plume Expansion into a Background Gas;107 8.4.3;5.4.3 Imaging;108 8.4.4;5.4.4 Kinetic Energy of Plume Species;110 8.4.5;5.4.5 Thin Film Growth;111 8.5;5.5 Laser Ablation of Polymers;117 8.5.1;5.5.1 Ablation Mechanism;118 8.5.2;5.5.2 Polymer Film Ablation;119 8.5.3;5.5.3 Film Pattern Transfer;120 8.6;5.6 Conclusions;122 8.7;References;122 9;Chapter 6: Processing with Ultrashort Laser Pulses;126 9.1;6.1 Introduction and General Considerations;126 9.2;6.2 Laser-Material Coupling;127 9.2.1;6.2.1 Nonlinear Absorption;128 9.2.2;6.2.2 Hot Electron Generation;129 9.2.3;6.2.3 Incubation;129 9.2.4;6.2.4 Resolution Below the Diffraction Limit;130 9.3;6.3 Dissipation Dynamics;131 9.3.1;6.3.1 Dissipation Channels;131 9.3.2;6.3.2 Transient Material Modification;131 9.4;6.4 Desor EAN/ISBN : 9783642132810 Publisher(s): Springer, Berlin
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